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Optimization of a rear system based on Titanium Nitride for a flexible CuInSe₂ solar cell

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Highlights

- Much less expensive method was adopted to deposit the absorbent layer CuInSe₂.
- The good crystallization of CISe deposited on glass requires a deposition temperature of 550°C. the gap value is in good agreement with the literature.
- The CISe layers deposited on stainless steel 316 exhibits a bad crystallization and stoichiometry.
- -The high deposition temperature of CISe promotes the diffusion of metallic impurities from stainless steel 316 to the absorbent layer.
- The TiN / Ti bilayer was investigated on the stainless steel 316 substrate at an ambient temperature.
- The TiN / Ti bilayer improves the surface condition of the stainless steel substrate.
- The TiN / Ti decrease the diffusion of iron from 9.7 %at. to 1.9 %at. and Cr from 3.8 to 0.5% at.

Abstract

Flexible thin film solar cells represent the future. This study concentrates on making CuInSe₂ based solar cells non rigid by depositing the rear molybdenum contact onto inox 316.

In order to overcome the Inox316 disadvantages such as the metallic impurities diffusion and the surface roughness, a bi-layer TiN/Ti have been introduced between the Mo rear contact and Inox 316. Two techniques have been employed: spray pyrolysis for CuInSe₂ and by cathodic magnetron sputtering for Mo/TiN/Ti. CuInSe₂ layers deposited onto glass substrates present high crystallinity with (112) preferred orientation at 550°C. However, these properties disappear for CuInSe₂ on Inox316 with missing peak (112) and fall in the ratio Se/Cu from 1.9 to 1.1.

According to EDS analysis, these results may be due to the Fe and Cu diffusion from Inox316 to CuInSe₂ film, this is why the presence of TiN/Ti bi-layer improves the surface condition of Inox 316 and reduces Iron presence from 9.7% to 1.9% and Cr from 3.8% to 0.5%; this confirms its efficiency to improve the solar cell performance using Inox316 substrate.

Keywords

CuInSe₂ solar cells, Inox 316, TiN/Ti, diffusion barrier, roughness substrate.

1. Introduction

Chalcopyrite CuInSe₂ based solar cells are now well established in the photovoltaic market due to their competitiveness to silicon [1,2] and their lowest elaboration cost, especially by spray pyrolysis [3,4]. Soda-Calcic glasses are widely used as substrate support for thin films solar cells [5]; however, many disadvantages appeared such as their fragility and their rigidity in addition to their thermal instability. This situation reduces considerably the possible configurations and shapes [6,7,8]. Indeed, flexible devices show high potential in the fabrication cost reduction. It is due to the possibility to perform the Roll-to-Roll process using a small thin film deposition machine with highest production rate [9].

The idea of the glass substrate replacement is currently the subject of many studies, especially by using non-oxydable steel, which, if used very thin can lead to flexible devices. The purpose of use of Inox 316 has two main reasons: Firstly, to elaborate flexible CuInSe₂ solar cells to widen the range of their use [10]. Secondly to reduce the Molybdenum matter which very expensive by this way, we lower the global CuInSe₂ solar cell cost and thus we can make it competitive. Technically, the steel thermal conductivity [4] can contribute to the CuInSe₂ grains growth in addition to a high mechanical resistivity against external forces. However, the thermal diffusion of the metallic elements (Iron and Chromium) may be detrimental [1,11,12], in addition to an important substrate roughness [13,14]. T. Eisenbarth et al have shown that the Fe diffusion may reduce the solar cell quantum efficiency [13]. Also, residual constraints between Mo and Inox may lead to a peeling off and defects formation because of the thermal incompatibility during CuInSe₂ deposition [15,16]. For this purpose, many works focused on the diffusion barrier deposited onto the metallic substrate, such as ZnO [17], Cr₂O₃ [11], Cr [13], Mo-N [18], Al₂O₃[19], Ti/SiOx [20].

The present paper concerns the utilization of Titanium Nitride TiN on Inox 316 with molybdenum as rear contact [21]. However, in order to have high adhesion of TiN on Inox, we must pre-deposit a Titanium layer as sandwich between them. i-e, the diffusion barrier in the solar cells is the Bilayer TiN/Ti. Its role is the diffusion reduction, also by the reduction of the roughness. In another side, the thermal coefficient mean value for TiN is 9.10^6 K^{-1} which may reduce considerably the constraints during CuInSe₂ deposition (Inox thermal coefficient = $11 \times 10^6 \text{ K}^{-1}$, Mo thermal coefficient = $5.9 \times 10^6 \text{ K}^{-1}$) [16]. One can also notice from the electrochemical results done by H.Omrani et al. that the resistance to corrosion is significantly improved when TiN films are deposited onto Inox 316 substrate [22].

On the other hand, for chalcopyrite based solar cells, molybdenum exhibits the ideal choice as rear contact [23,24], it occurs on the creation of an additional MoSe2/ CuInSe₂ ohmic contact [25] which increases the free carriers'mobility and consequently the electrical conductivity [26]. However, titanium nitride has a considerable electrical conductivity [27,28], hence more, it can be used in the same position than Mo as a back contact. This proposal allows to reduce the thickness of Mo and giving a real economical challenge since titanium is less expensive than molybdenum [29], and yielded to cheaper solar cells.

2. Experimental par

[32]:

CuInSe₂ thin films were deposited by spray pyrolysis method using 20%vol. ethanol based solution. This one was prepared from copper dichloride (CuCl₂.2H₂O) as copper source, Indium Trichloride (InCl₃) as Indium source and N,N,Diméthyl Sélén-urée (C₃H₈N₂Se) as Selenium source [3,30] (all chemical compounds were provided by Sigma Aldrich). The mixture concentration is 0.00795 M, the ratio Cu:In:Se is fixed to 1:1:3,3 and the excess in C₃H₈N₂Se is used to compensate the Selenium loss during deposition due its low evaporation

energy with annealing [31]. CuInSe₂ is formed according to the chemical reactions below

The solution was sprayed with an Argon flow rate of 12 ml/mn and a pressure of 2 Bar; the distance nozzle-substrate was fixed at 30 cm. Deposition was made onto two substrate's type: glass and Inox 316 for a duration of 10 min. Three substrate's temperatures were used: $T_S = 450^{\circ}\text{C}$, 500°C and 550°C .

The bilayer TiN/Ti diffusion barrier deposition was done using reactive Radio-Frequency (RF) magnetron sputtering technique in a Nitrogen–Argon gas atmosphere [33] onto metallic substrate Inox 316. For the sputtering deposition, a commercial Titanium target has been used with purity 99.95%. A secondary pump connected to a primary pump ensures a based pressure of 4.10^{-7} mbar in the deposition chamber. Nitrogen injection was measured with a flow meter to access a total pressure $P_T = 23$ mTorr. In order to avoid a films' contamination, the target undergoes a pre-sputtering for 90 mn between each sample to make it cleaner.

Molybdenum films (rear contact for CuInSe₂) were deposited by using cathodic DC sputtering with a Molybdenum target with 99.95% purity, on two types of substrates: TiN/Ti/Inox 316 and Inox 316. After deposition, Mo films were annealed in Argon atmosphere at 550°C to have the same elaboration conditions for CuInSe₂ by Spray Pyrolysis.

Structural properties were obtained using a X-ray diffractometer SEIFERT 3003 PTS $(K_{\alpha l}(\lambda=1.54050\ \text{Å}))$, while the morphology of the surface was determined by Scanning Electron Microscopy (SEM) using a JEOL JSM-IT100 equipment; thicknesses were measured directly from the sample's lateral view. Chemical composition was analyzed by Energy Dispersive Spectroscopy (EDS) (Oxford Aztek). Optical properties were deduced from UV-Visible spectroscopy with a Perkin Elmer Lambda 365 apparatus.

Figure 1 illustrates the CuInSe₂ based solar cell structure with Inox 316 as flexible substrate and TiN/Ti diffusion barrier.

Table 1 summarized all the samples elaborated during this work with the corresponding experimental conditions.

3. Results and Discussion

3.1. Optimization of the CuInSe₂ absorbing layer

Figure 2a presents the XRD spectra for the CuInSe₂ layers deposited onto glass substrates at different temperatures. One can remark the presence of four peaks in all diffractograms, indexed as (112), (220), (400), and (424) according to the JCPDS 23-0209 file of CuInSe₂ chalcopyrite [34-35]. This confirms that films are polycrystalline.

However, the diffraction of the CuInSe₂ layer deposited at temperature of 550 °C shows four other peaks indexed as (301), (312), (323), (415) plans, according to the same JCPDS file 23 - 0209. Technically, the appearance of these peaks in this layer reveals to the superlattice reflections of the ordered chalcopyrite structure [36]. However, the peak (220) has a high and nearly constant intensity with all substrate temperatures with almost similar FWHMs (Figure 2b)

Figure 2c shows that the peak intensity (112) get improved and its diffraction angle 20 changed towards the preferential position (JCPDS 23-0209) with an increases of the substrate temperature, this observed peak could be related to a shift in lattice parameters to make it larger, probably due to a slight variations in Cu content in the system [30]. An interesting decrease of the ratio $I_{(220)}/I_{(112)}$ (Figure 2d) confirms a good orientation for CISe-3 at 550°C [37].

Figure 3 presents the evolution as a function of the deposition temperature of the atomic ratios (Cu/In) and (Se/Cu) determined by EDS. Results show that the (Cu/In) ratios of the films vary from 1.0 to 1.1 and are similar to those of precursors. A loss in Selenium is observed when passing from the solution to the films [32], the solution presents a (Se/Cu) ratio comprised between 3.0 and 3.5 (to have an excess of Selenium) while the films present values of 1.8 and 1.9, close to 2.0. The excess of Selenium in the precursor solution has permitted the deposition of merely stoichiometric CuInSe₂ layers. We notice also, a Na signal in the

CuInSe₂ layer (Figure 3b). Several researchers have shown this diffusion and also its critical role in the CuInSe₂ absorbent layer to improve its performances [38,39].

SEM images in Figure 4 illustrate the CuInSe₂ films morphology at different substrate temperature. Two kinds of grains were observed: big spherical grains (230 nm to 280 nm) [31] for layers CISe-1 and CISe-2 deposited at 450°C and 500°C and small light grains shaped like eagles (200 nm to 400 nm) for CISe-3 layer deposited at 550°C, this can be explained by the effect of the supplied energy with the heating on atomized atoms [40].

Figure 5 shows the absorbance curves of CuInSe₂ layers deposited at different substrate temperatures. Films have good optical absorption, especially in the visible range. Remarkably, A better absorption with the coefficient value of $9.16.10^4$ cm-1 at $T_S = 550$ ° C has been obtained.

From the figure 5b, the energy gap decrease from 1.32 eV to 1.07 eV for CuInSe₂ film deposited at 550°C. According to Weidong Wang et al, this is due to the density of states at the interfaces and the defects energy level on the surface [41], however, S. Agilan et al, found an enhancement in the grain size [42], also, B.J. Babu et al, attributed the energy gap variation for layers deposited by techniques non using vacuum to the defects structure and grain boundaries [6].

3.2. CuInSe₂ deposited onto Inox 316 substrate

Figure 6a presents the XRD spectra for CuInSe₂ layers deposited on glass and Inox 316 substrates and the Inox substrate alone. A polycrystalline structure of the Inox substrate is observed with peaks indexed as (111), (220) for Cr_{0.19}Fe_{0.7}Ni_{0.11} (JCPDS 33-0397), three peaks (110), (200) and (211) for Ni-Cr-Fe (JCPDS 85-1410) [43]. However, the film CISe-3 deposited onto glass depicts four peaks indexed as (112), (220), (400) and (424) of CuInSe₂,

in addition, the film CISe-3 on Inox 316 exhibits two points: a total absence of peak (112), secondly, the detail displayed on the zoom (Figure 6c) notes that the CISe-5I peak is diffracted towards the same diffraction position of the peak (110) of Ni-Cr-Fe as mentioned on JCPDS 85- 1410, we can also compare the obtained FWHMs to maintain the absence of the CuInSe₂ peaks on diffractogram of CuInSe₂ deposited on Inox, the peak appeared toward 44.5° resembles that of the Inox substrate (figure 6c). This good crystallinity of CuInSe₂ on glass substrate (figure 6b) was somehow lost when deposition is performed on Inox 316; it is probably related to structural defects that appeared in parallel with the diffusion of metallic impurities [20].

Figure 7 shows the chemical ratios (Cu/In) and (Se/Cu) for CuInSe₂ films deposited at 550°C on glass and Inox 316 substrates. One can remark that the (Cu/In) ratios are identical, while the (Se/Cu) ratio of the film on Inox 316 drops compared to the one on glass. This decrease is essentially due to the Selenium loss during deposition onto Inox; the CISe-3 layer deposited onto Inox is not stoichiometric, confirming its crystallographical results.

SEM images for CISe-3 on glass and Inox 316 are shown in Figure 8. One can notice that the morphology of the film deposited on glass is more homogeneous, the grains shaped like eagles in both cases, Grains are bigger on Inox 316 (900 nm to 1200 nm) than those observed on glass (200 nm to 400 nm). The films surface looks like a spider canvas [44]. It should be noted that the state of morphology of CuInSe₂ on Inox is not desirable; it also reflects degradation of CuInSe₂ properties. The solution is the introduction of the TiN/Ti barrier layer to avoid the metallic elements diffusion and by mean of consequence to main the good CuInSe₂ properties.

Figure 9 illustrates the EDS data of the CISe-3 layer deposited at 550°C on Inox substrate. Figure 9a shows that Inox is composed of three main elements: Iron, Chromium and Nickel.

The EDS analysis of the film (Figure 9b) was made by decreasing the beam energy from 20 KeV to 8 KeV. This decrease permits to reduce the analyzed depth in sample in order to consider only the layer not the layer plus the substrate. We see that the substrate's elements (Fe, Cr, Ni) reduce as beam energy decreases, in correlation to an increase of Se in the CuInSe₂ layer. Nickel signal disappears at 8 KeV, Fe and Cr signals are still observed. One can conclude that at the tension of 8 KeV allows to analyze only the (top) CuInSe₂ layer and so, that observed Fe and Cr are diffused elements from the substrate in the CuInSe₂ film [35,45]. This may be responsible for the crystallization loss of the CISe-3 layer deposited on Inox at 550°C, as seen in Figure 6.

3.3 TiN/Ti diffusion barrier:

In order to avoid the diffusion of the substrate's elements to the CuInSe₂ films, diffusion barrier based on Titanium Nitride TiN has been used. Implantation of TiN on Inox substrate requires an intermediate layer of Titanium in order to ensure good adherence. The deposition conditions used are optimized: $P_{RF} = 200$ W, %vol. $N_2 = 50$, $p_T = 20$ mTorr [46], thermally, the unstable behavior of Inox required a using of different deposition temperatures $T_S = 25^{\circ}$ C, 500° C or 700° C.

XRD spectra in Figure 10 show scattered peaks along the diffraction domain. These are indexed (110), (200), (211), (330) and (220) according to our Inox substrate. However, it should be noted that for all the bilayers TiN/Ti, two TiN peaks (111) and (200) according to Titaium Nitride JCPDS 06-0642 are presented. These peaks confirm a polycrystalline structure of TiN. Nevertheless, relatively better intensities were observed for the film deposited at 25 °C [47]. This temperature shows a small peak around $2\theta = 38^{\circ}$ correspond to the tie layer of Ti (111) according to JCPDS file 44-1294 [29].

SEM images in Figure 11 illustrate a high surface density with similar morphologies. One can distinguish circular grains filling the surface [48]. The curly condition of the substrate has also affected and shown on the deposited film.

EDS results in Figure 12 show that the (N/Ti) ratio in TiN/Ti bilayers decreases as the deposition temperature increases. The N/Ti ratio is close to stoichiometry for $T_S = 25^{\circ}$ C, suggesting that the annealing of the Inox 316 substrate (deposition at high temperature) is prejudiciable to the deposition of stoichiometric TiN.

3.4. Mo rear contact

Mo films were deposited at $T_S = 25^{\circ}\text{C}$ by DC sputtering on Inox 316 and TiN/Ti/Inox 316 substrates. The samples underwent a heat treatment under Ar at a temperature of 550 ° C., in order to put this system in the same atmosphere as that of the CuInSe₂ absorber and also to promote the impurities diffusion.

From SEM image in Figure 13, one can remark strong polishing streaks of the bare Inox substrate, reflecting its high roughness. The Mo layer above also shows a high roughness, however, it is reduced compared to the bare substrate and to the layer deposited on Inox alone when deposited on the TiN/Ti/Inox substrate. This will certainly reduce the electric leakage in the CuInSe₂ solar cell [49].

M.Yazıcı et al showed that the layer of TiN deposited on the Inox 316 makes it possible to enhance its hardness and its mechanical strength, particularly against wear [50]. Thus, it represents a better material catcher of this roughness compared to Mo.

The two deposited Mo layers have undergone annealing under Argon gas to quantify a possible Inox substrate's diffusion while annealing at the CuInSe₂ deposition temperature. We have chosen $TS = 550^{\circ}C$ which is the optimized value for obtaining stoichiometric crystalline

CuInSe₂ (see paragraph 3.1). Figure 14a shows the EDS contents of Fe and Cr for Mo layers deposited on Inox 316 and TiN/Ti/Inox 316 and annealed. There is a strong presence of Fe and Cr when the deposition was performed on Inox alone. it has clearly appeared in the EDS spectrum of Mo (Figure 14b) with the presence of low intensity of Fe and Cr lines. Unlike, the use of a TiN/Ti diffusion barrier obviously reduces the Fe rate (from 9.70 %at. to 1.8 %at.) and Cr (3.8 %at. to 0.5 %at.) for the samples.

From these results, the bilayer TiN/Ti barrier diffusion efficiency is confirmed to avoid the migration of the substrate metallic elements in the rear contact Mo layer. The TiN/Ti/Inox 316 substrate will be soon used as a support for CuInSe₂ solar cells.

4. Conclusion

The present study is dedicated to the use of a metallic Inox 316 substrate instead of glass for CuInSe₂ based solar cells. This will help to improve properties such as flexibility and mechanical resistance. CuInSe₂ absorbing layers were deposited by spray pyrolysis onto glass and Inox 316 substrates. A comparative study has been performed showing a high crystallinity of CuInSe₂ on glass at deposition temperature of 550°C. No crystallinity was observed for CuInSe₂ on Inox 316 substrate. EDS analysis for CuInSe₂ layers deposited on Inox 316 show that the ratio (Cu/In) is almost kept constant compared to the precursors solution, while the (Se/Cu) ratio is close to 2 confirming the stoichiometry of CuInSe₂ on Inox 316. SEM images reveal that CuInSe₂ grains are shaped like eagles on glass and Inox but they are bigger (900 nm to 1200 nm) for CuInSe₂/Inox 316 than for CuInSe₂/glass; layers 'surface appear like a spider canvas. Different beam energies (8 kV to 20 kV) have been used in EDS analysis to study the presence of metallic elements (Fe, Cr) in CuInSe₂ layers, due to diffusion at high deposition temperature. When energy beam is low (8 kV), only the CuInSe₂ layer is analyzed, but Fe and Cr are still observed, demonstrating their diffusion from the Inox substrate. To

avoid such diffusion, TiN/Ti bilayer was deposited on Inox 316 at 25°C, 500°C and 700°. N/Ti ratio is close to stoichiometry for the $T_S = 25$ °C. By adding the rear Mo contact to the TiN/Ti barrier, it is found that the metallic Fe and Cr diffusion is drastically reduced: Fe content falls from 9.7 to 1.8 %at., while Cr falls from 3.8 to 0.5 %at. We conclude that the Inox 316 substrate can be used in CuInSe₂ based solar cells by introducing a TiN/Ti diffusion barrier.

Declaration of interests

The authors declare that they have no known competing financial interests or personal relationships that could have appeared to influence the work reported in this paper.

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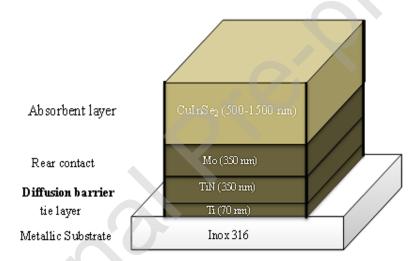


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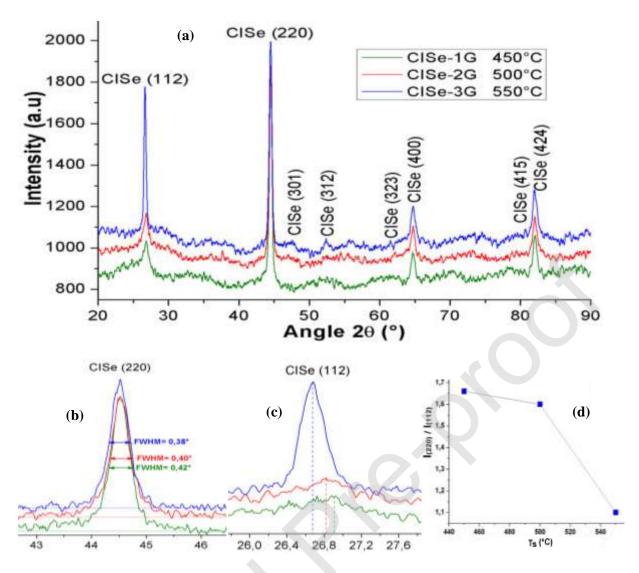


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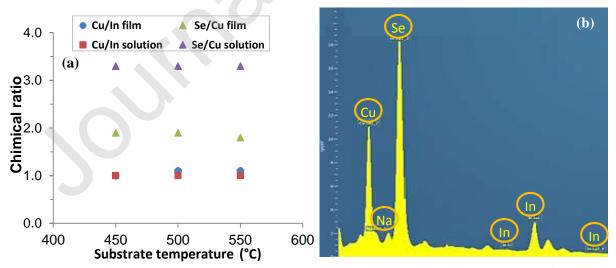


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CISe-1G 450°C CISe-3G 550°C

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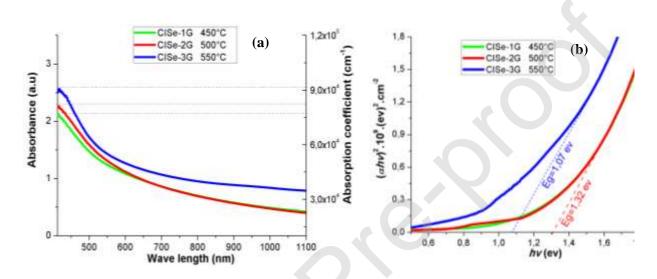


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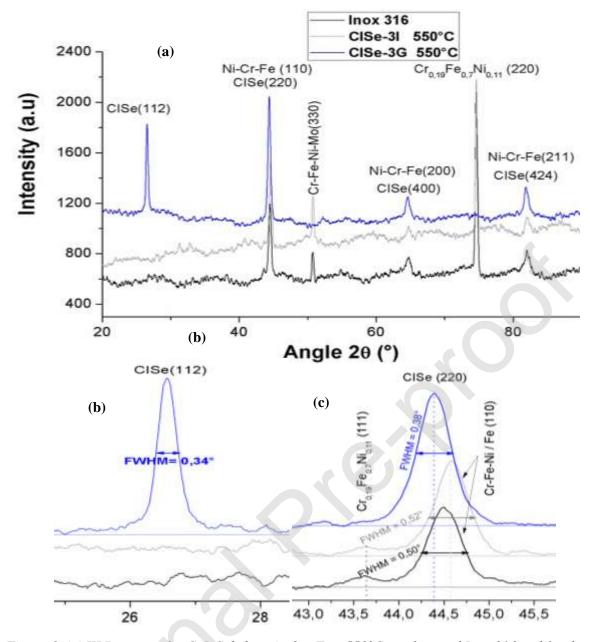


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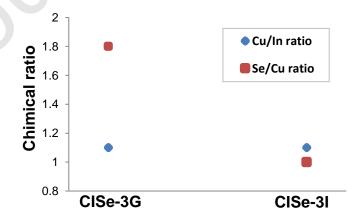


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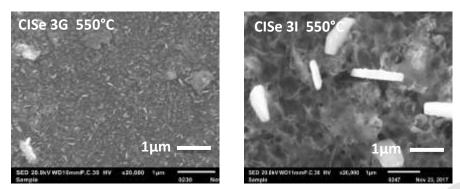


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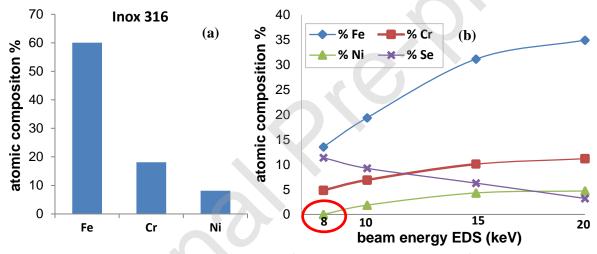


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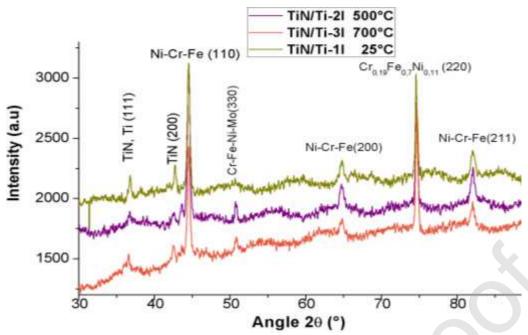


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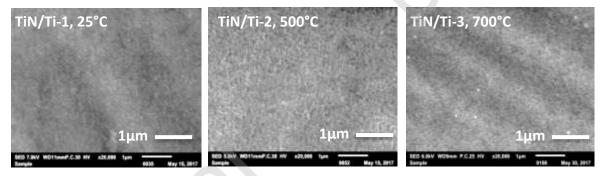


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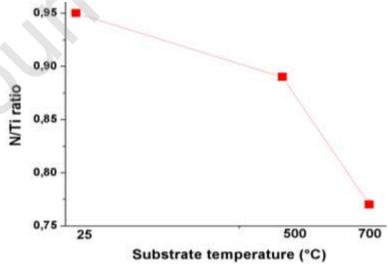


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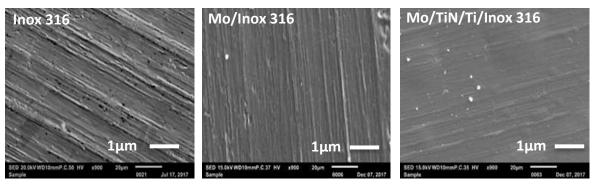


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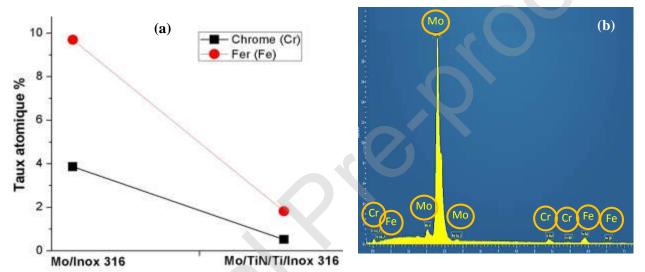


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Tables

Table1: Prepared CuInSe₂, TiN/Ti and Mo films along with their deposition conditions.

Films	Substrate	Deposition technique	Fixed parameters	Substrate Temperature
CISe-1G	Glass	Spray Pyrolysis	Argon pressure 2 bars Distance 30 cm	450°C
CISe-2G				500°C
CISe-3G			Deposit speed 12 ml/min	550°C
CISe-3I	Inox 316		Deposit time 10 min	550 C
TiN/Ti-1I		RF Sputtering	RF power 200 W	25°C
TiN/Ti-2I	Inox 316		Nitrogen content 50 %vol. Total pressure	500°C
TiN/Ti-3I			20 mTorr Deposit time 90 min	700°C
Мо	Inox 316		Gas: Argon	
	TiN/Ti/Inox 316	DC Sputtering	Deposit time: 180 min Substrate temperature: 25°C	